



PATENT
8045-1015

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Shinichi NAKATA et al.

Conf. 6017

Application No. 10/676,132

Group 1725

Filed October 2, 2003

Examiner Maria A. Elve

MASK FOR LIGHT EXPOSURE AND METHOD
FOR MANUFACTURING LIQUID CRYSTAL
DISPLAY APPARATUS EMPLOYING SAME

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 1, 2005

Sir:

Responsive to the Official Action of May 3, 2005,
please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this
paper.

Remarks begin on page 3 of this paper.